

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Mark S. Chace et al.

Examiner: Joseph W. Drodge

Serial No.: 10/695,374

Art Unit: 1723

Filed: October 28, 2003

Docket: FIS920030172US1 (16645)

For: PROCESS FOR REMOVING
IMPURITIES FROM LOW DIELECTRIC
CONSTANT FILMS DISPOSED ON
SEMICONDUCTOR DEVICES

Dated: October 16, 2006

Confirmation No.: 5323

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexander, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the final Office Action dated August 16, 2006, please amend the
subject patent application as follows:

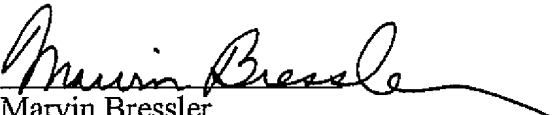
Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 8 of this paper.

CERTIFICATE OF ELECTRONIC FILING

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Dated: October 16, 2006


Marvin Bressler